

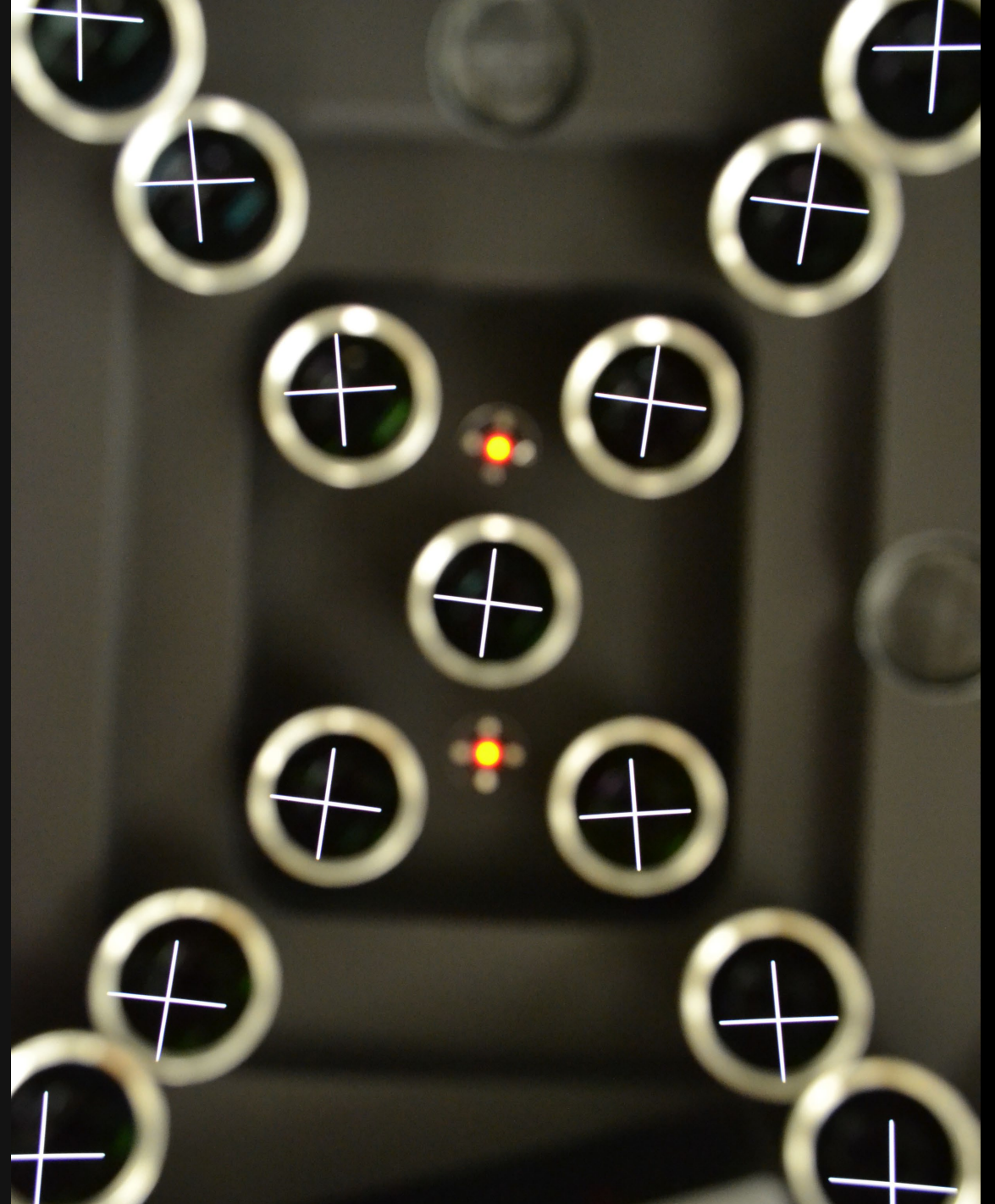
The measurement of object distance for projected virtual objects using a scanning pentaprism and digital alignment telescope

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OPTO 13373-8



An imager test scenario must be consistent with the use case.

How do we ensure

Conjugate Distance

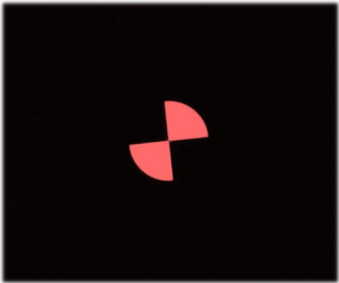
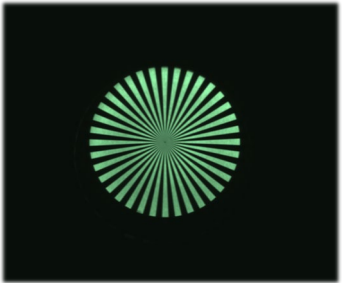
regardless of

Aperture Size

Wavelength Spectrum

or

Target Shape ?

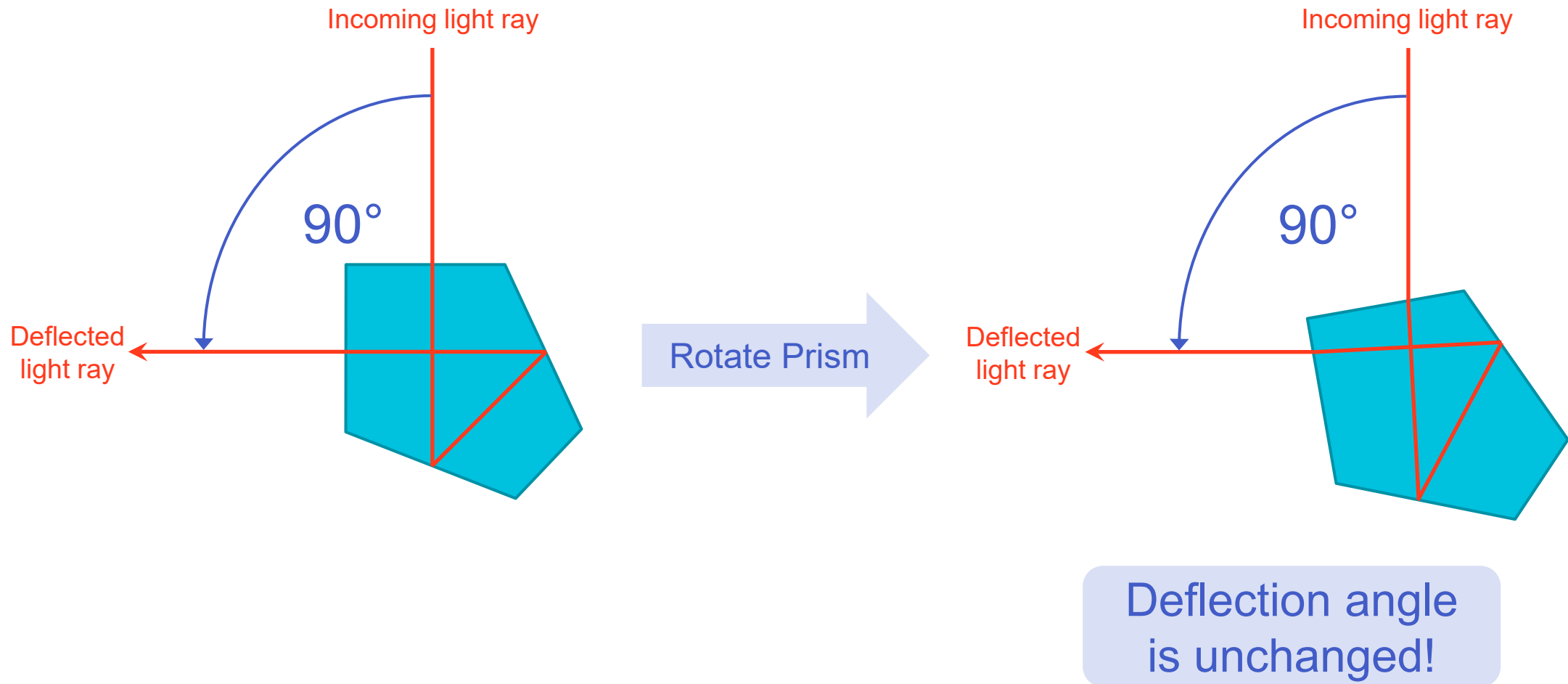


There are several methods for ensuring collimation...

Method	Restriction				
	Pinhole Source	Monochromatic Source	Instrument EFL >> Collimator EFL	Relay Optic > Collimator Aperture	Accommodating Features in Collimator
Laser Unequal Path Interferometer	×	×	✓	×	×
Calibrated Camera	✓	✓	×	×	✓
Shack-Hartmann Wavefront Sensor	×	✓	✓	×	✓
Shear Plate Interferometer	×	×	✓	×	✓
Autocollimation	✓	✓	✓	×	×
Scanning Pentaprism	✓	✓	✓	✓	✓

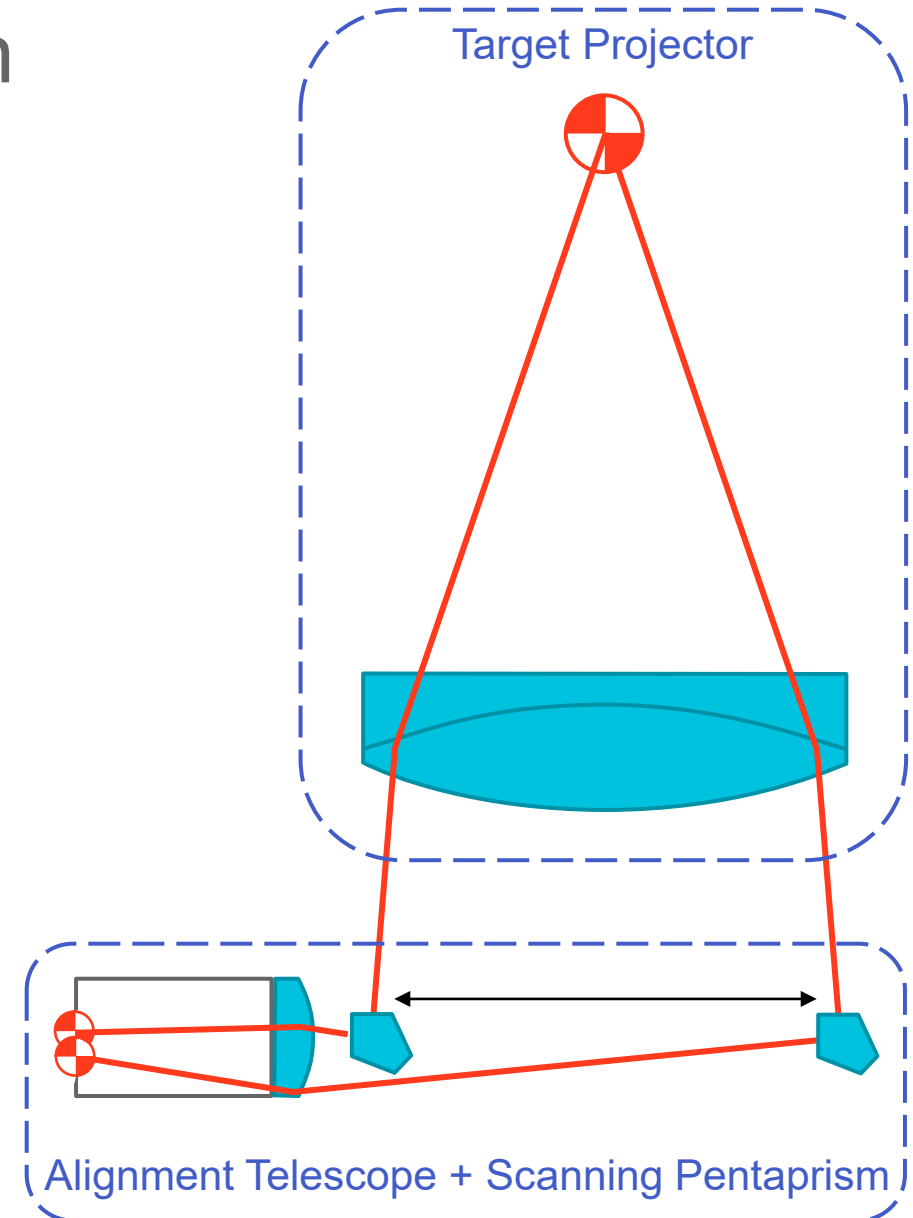
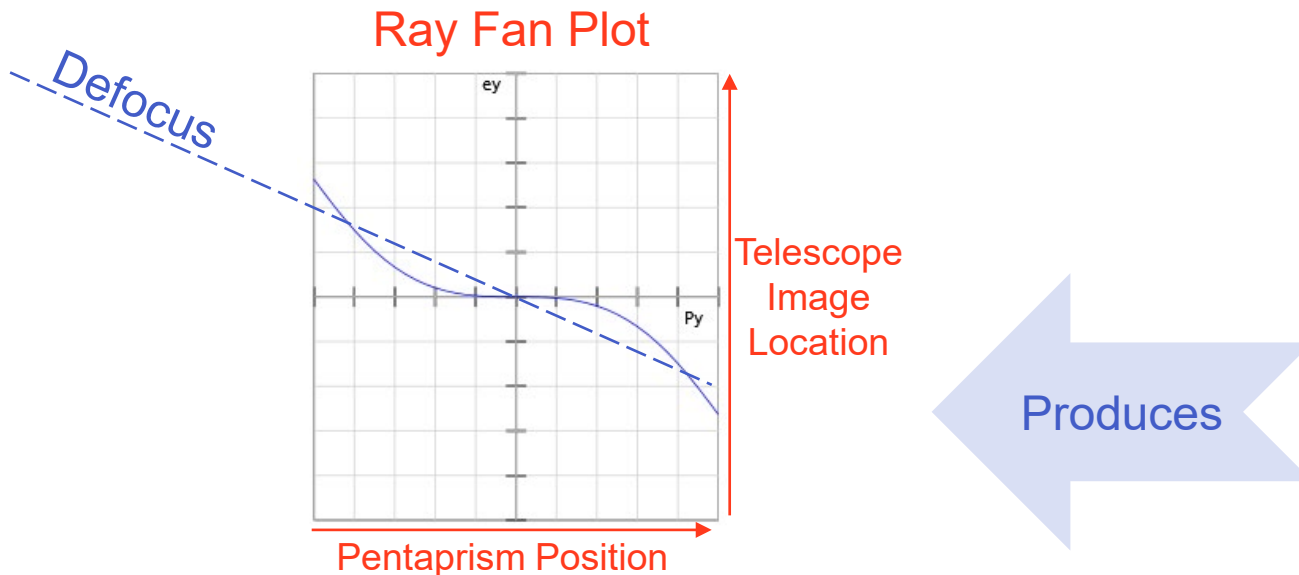
The Scanning Pentaprism has the versatility we need.

A pentaprism provides a constant deflection angle.



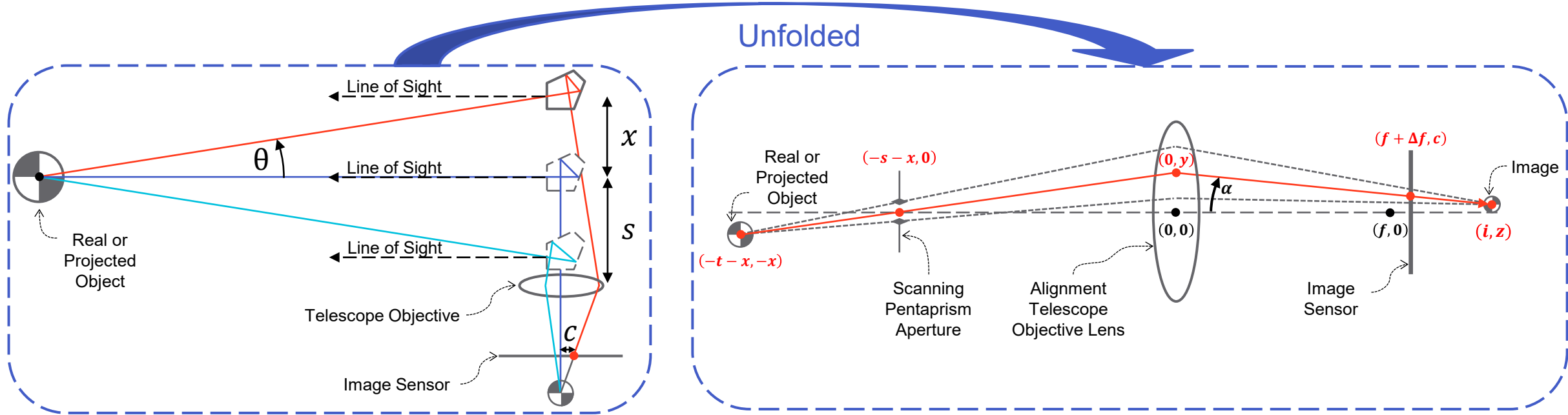
The Scanning Pentaprism Approach

- Alignment telescope and collimator are rigidly affixed to each other.
 - Moving only the pentaprism drastically reduces straightness required of the linear guideway
- Location of the telescope image is proportional to angle of ray collected from target projector



Geometrical Optics Analysis — See Manuscript

Pentaprism = Aperture Stop → Defines line of sight in object space



- Known by design {
- s — Nominal aperture spacing
 - f — Telescope objective focal length
- Monitored during operation {
- x — Pentaprism position
 - c — Chief ray height on sensor
- Quantity to be calculated {
- t — Object distance

- $y = \frac{x(t+x)}{t-s} - x$ Chief ray height at telescope objective
- $z = \frac{x}{\frac{(t+x)}{f} - 1}$ Image location
- $\tan \alpha = \frac{z-y}{i}$ Chief ray angle in image space
- $c = z - (i - f - \Delta f) \tan \alpha$ Chief ray height on image sensor

The Scanning Pentaprism Demonstrator

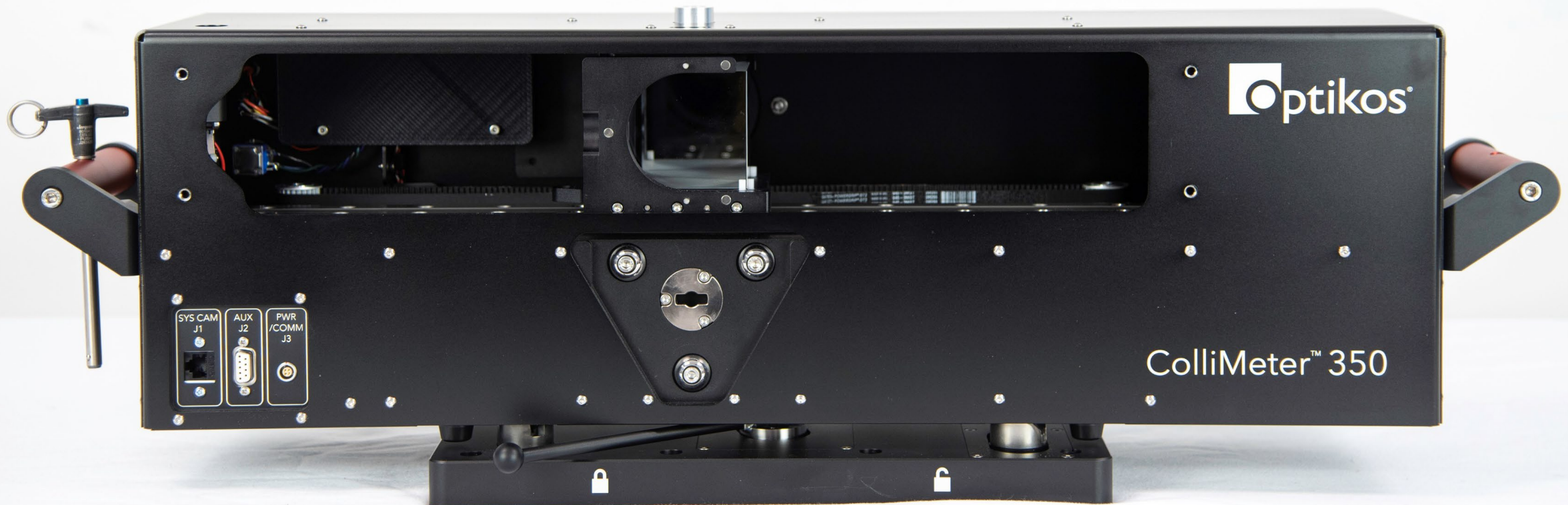
Scan Range
350 mm

Weight
16.9 kg

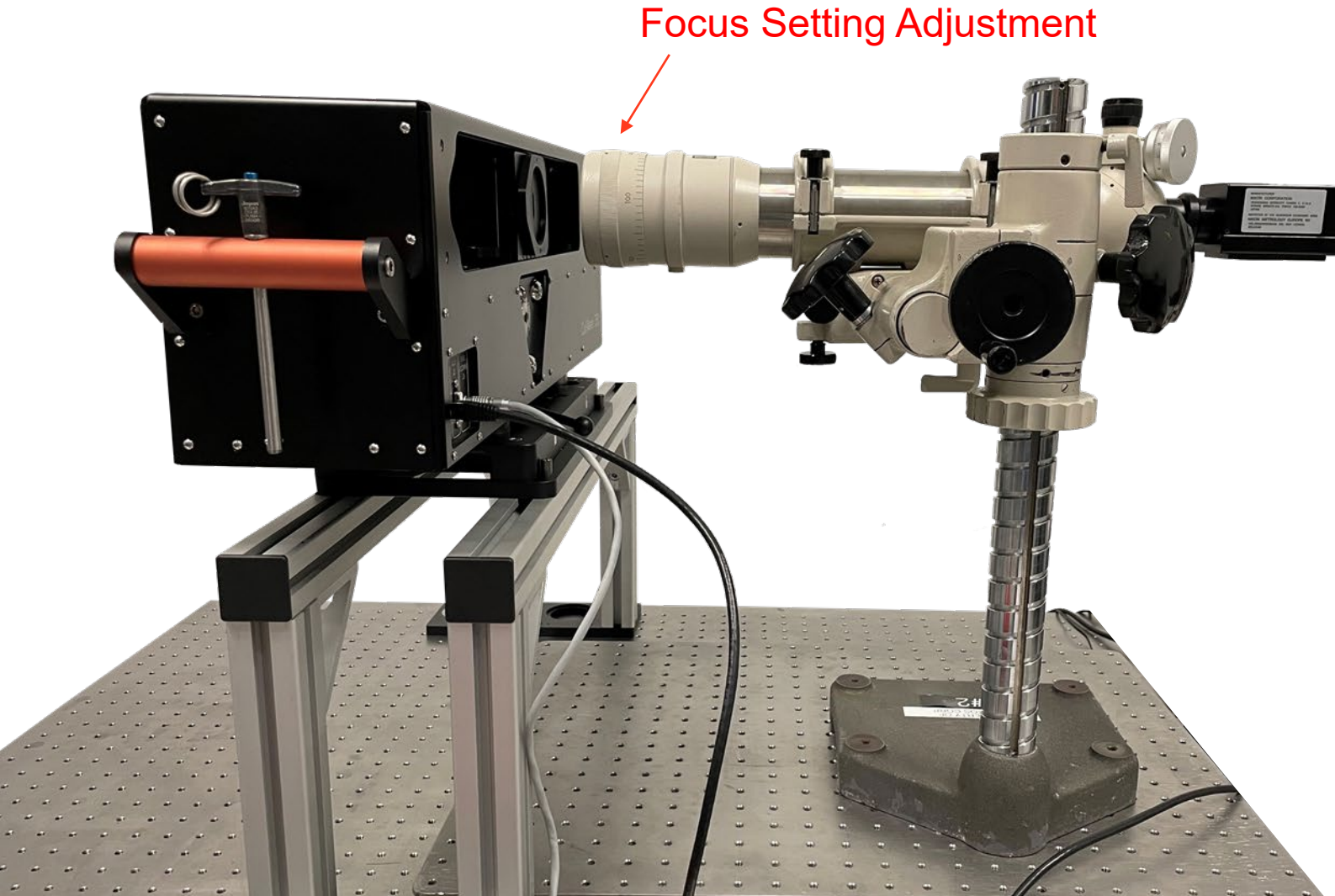
Pixel Subtense
2 arcsec

Full Field of View
1.38°

Spectral Range
300-1000nm



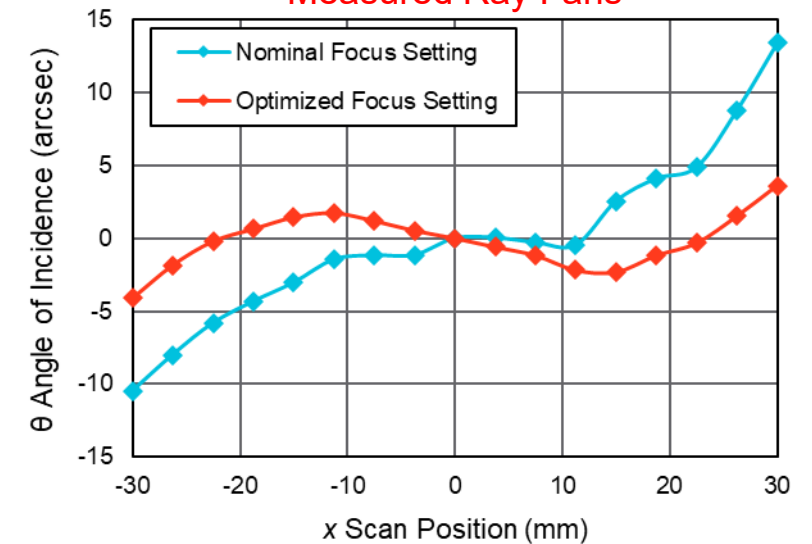
Compensating Spherical Aberration



Autocollimator Crosshair in Live Video

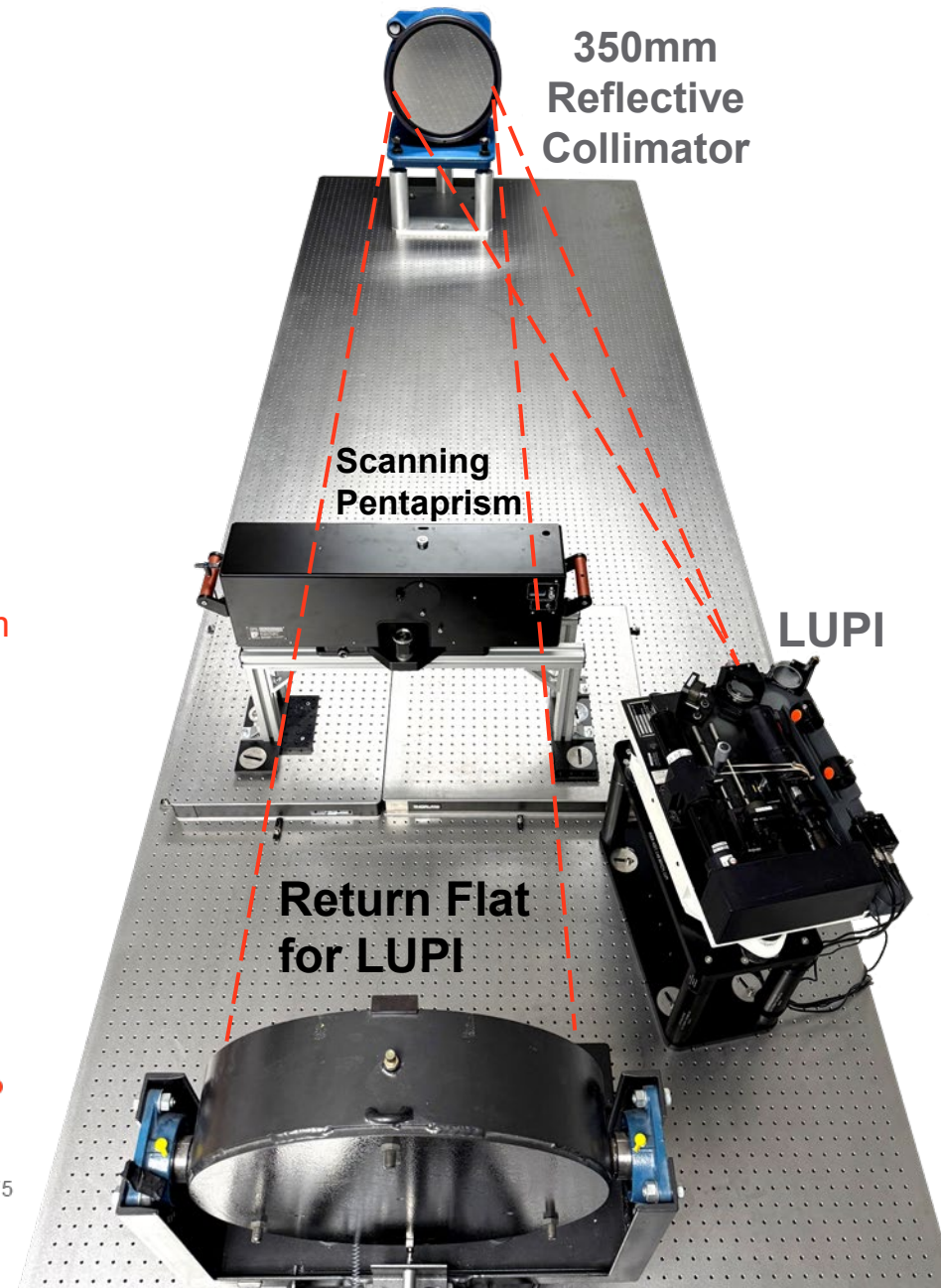
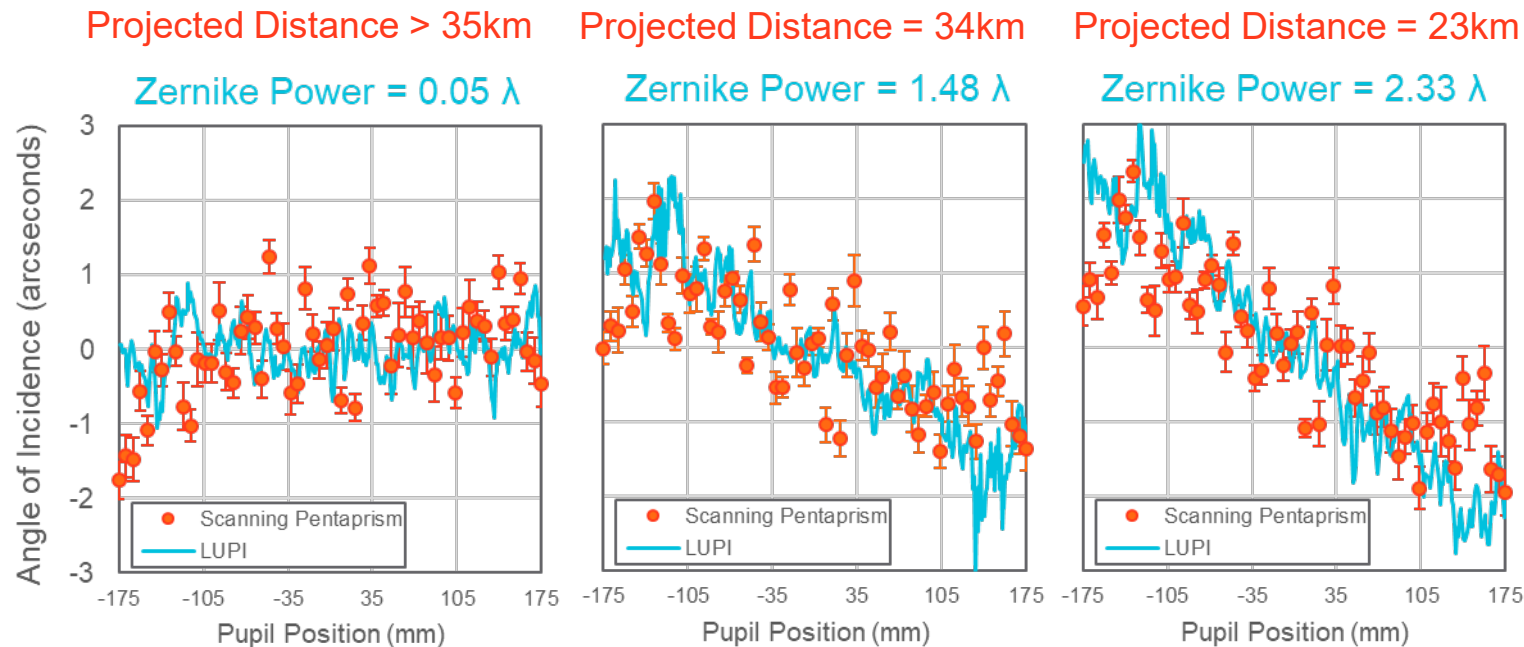


Measured Ray Fans

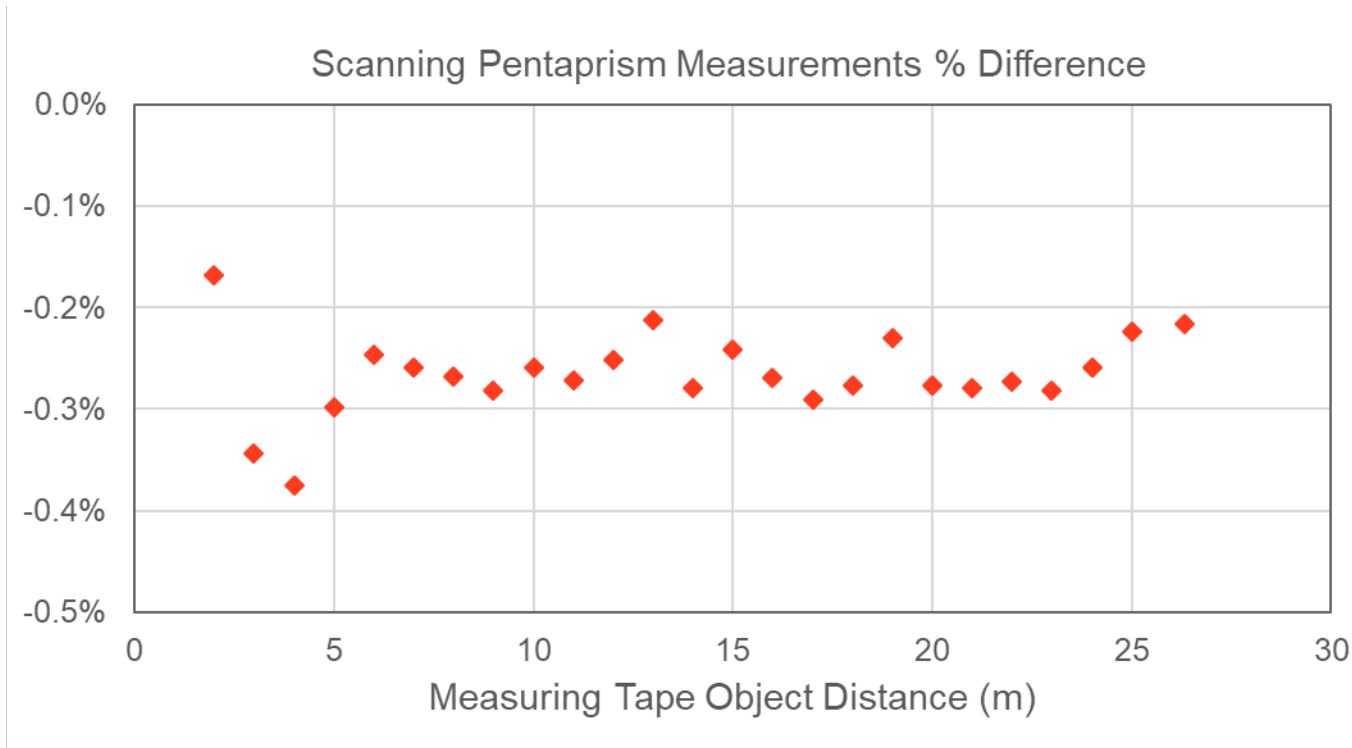


Measuring Departure from Collimation

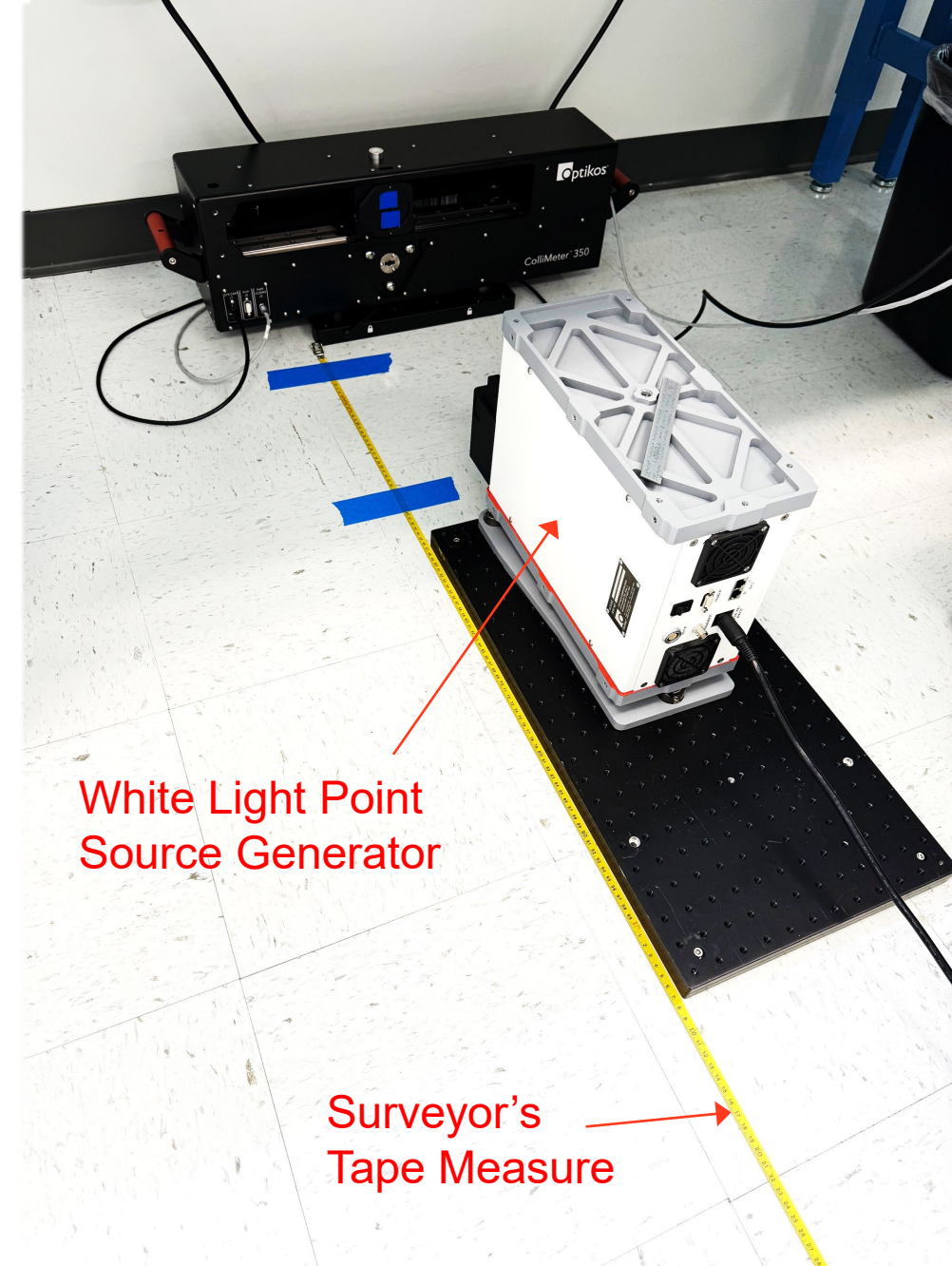
- Laser unequal path interferometer (LUPI) is both:
 1. Point source for collimation measurement
 2. Independent measurement of collimation



Measuring Finite Conjugates



- The scanning pentaprism is a versatile technique for determining conjugate distance of any optical beam!



Measuring Parallax



- The reticles of telescopic sights can be measured provided uniform background illumination.
- For the case of rifle scopes, this can directly measure the “zero parallax distance” on the objective side of the scope.



Thank you!

Come see the scanning pentaprism instrument at Optikos booth #841

Acknowledgments

- Lucas Delbanco
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- Dr. Stephen D. Fantone
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